



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 21, 2026

IGI Report Number

LG793640508

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE MODIFIED BRILLIANT

Measurements

16.84 X 7.88 X 4.49 MM

GRADING RESULTS

Carat Weight

4.13 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG793640508

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS

Thick To Very Thick (Faceted)

15%

35.5%

58%

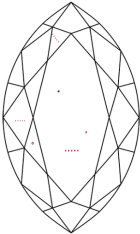
57%

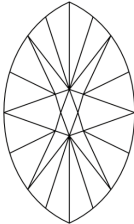
Large



Sample Image Used

CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



April 21, 2026

IGI Report Number

LG793640508

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE MODIFIED BRILLIANT

Measurements

16.84 X 7.88 X 4.49 MM

GRADING RESULTS

Carat Weight

4.13 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG793640508

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



IGI

April 21, 2026

IGI Report No LG793640508

MARQUISE MODIFIED BRILLIANT

16.84 X 7.88 X 4.49 MM

Carat Weight

4.13 CARATS

Color Grade

F

Clarity Grade

VS 1

Depth

57%

Table

85%

Girdle

Thick to Very Thick (Faceted)

Culet

Large

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG793640508

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa